CALIFORNIA INSTITUTE OF TECHNOLOGY
MASSACHUSETTS INSTITUTE OF TECHNOLOGY

DCN No. E000357-00-D
SHEET 1 OF 1

DOCUMENT CHANGE NOTICE (DCN)

DOCUMENT No. (DOC-REV-GP. ID)	TITLE	NEW REV.
M000179-B-L	SOP, COS LVEA Assembly IR Alignment Laser, LLO	B

CHANGE DESCRIPTION (FROM/TO): Change paragraph 4.5 to OD 2.7 for 940nm and 980nm wavelength

REASON FOR CHANGE: laser description

ACTION: ☐ Incorporate change ☐ Attach DCN to drawing(s) ☐ Other action (specify):

DISPOSITION OF HARDWARE (IDENTIFY SERIAL NUMBERS)

- ☐ No hardware affected (record change only)
- ☐ List S/Ns which comply already:
- ☐ List S/Ns to be reworked or scrapped:
- ☐ List S/Ns to be built with this change:
- ☐ List S/Ns to be retested per this change:
- ☐
- ☐
- ☐
- ☐

DCN DISTRIBUTION (X=incl. docs)

	Barish	Coles
X Coyne	Lazzarini	Lindquist
Raab	Sanders	Shoemaker
X Stapfer	Tyler	Weiss
Whitcomb	SCIENCE	

X Michael Smith, X J. Kern

SAFETY, COST, SCHEDULE, REQUIREMENTS IMPACT? ☐ No ☒ Yes (If yes, enter Change Request number)

APPROVALS:		DATE	OTHER APPROVALS (specify)	DATE
ORIGINATOR:	Michael Smith MR Smith	7/10/00		
TASK LEADER:	Dennis Coyne			
GROUP LEADER:	Dennis Coyne 7/10/00			
DCC RELEASE:	Linda Turner Linda Turner 7/14/00			